

Title (en)
ELECTRON EMISSION ELEMENT

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Application
EP 87113260 A 19870910

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• JP 28424086 A 19861201
• JP 29768386 A 19861216

Abstract (en)
[origin: EP0259878A2] An electron emission element comprises a P-type semiconductor substrate (1) and electrodes (2, 3) formed on both ends of the semiconductor substrate. A voltage is applied between said electrodes. The P-type semiconductor substrate is irradiated with light to emit the electrons, generated in the P-type semiconductor substrate by photoexcitation, from an electron emitting face (4) at an end of the P-type semiconductor substrate.

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CPC (source: EP)
H01J 1/308 (2013.01); **H01J 1/34** (2013.01); **H01J 2201/3423** (2013.01)

Citation (search report)
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